

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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In re application of	: Attorney Docket No.
	: CHAIX
Applicant: Catherine CHAIX et al	:
	:
Application No. Unknown (US National Phase	: GAU: Unknown
Of PCT/FR03/01868	:
Filed: June 18, 2003	:
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Filed: Herewith	: Examiner: Unknown
	:
For: "MATERIAL EVAPORATION	:
CHAMBER WITH DIFFERENTIAL	:
VACUUM PUMPING"	:
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MAIL STOP PCT  
 Commissioner for Patents  
 P.O. Box 1450  
 Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT

SIR:

Prior to calculation of the filing fee, please amend the above application as follows:

IN THE CLAIMS:

*Please AMEND the claims to read as set forth in the following listing of claims.*

1. (original) An evaporation chamber of materials including a vacuum chamber (10), a first pumping unit (13) to pump said chamber and sources of material, characterised in that:

- a wall (23) liable to provide total or partial vacuum tightness, delineates within the vacuum chamber (10) a first volume (25) pumped by said first pumping unit (13) and a second volume (22) pumped by a second pumping unit (24),